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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Notice of Allowance Mailed: September 8, 2004
Issue Fee Paid: December 3, 2004

Application No.: 09/871,600
Filing Date: May 31, 2001
Applicant: Akira ARAI
Group Art Unit: 1742
Examiner: John P. Sheehan
Title: MAGNETIC POWDER, MANUFACTURING METHOD
OF MAGNETIC POWDER AND BONDED MAGNETS
Attorney Docket: 9319A-000222

Director of the United States Patent and Trademark Office
P.O. Box 1450
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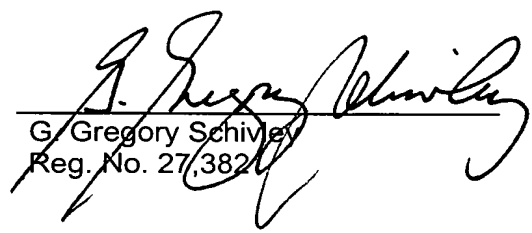
MAKE OF RECORD LETTER

Sir:

Please make the information set forth on the enclosed Form 1449 of record in this file.
The listed documents were cited in a search report for a corresponding European patent application. However, Applicant makes no admission that the disclosures in these documents affect the presumption of validity for the claims in this issued patent.

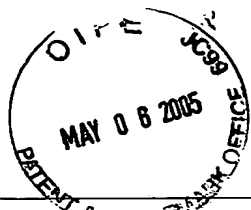
Respectfully submitted,

Dated: May 6, 2005

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INFORMATION DISCLOSURE CITATION**

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Sheet 1 of 1

ATTORNEY DOCKET NO.

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SERIAL NO.

09/871,600

APPLICANT

Akira ARAI

FILING DATE

May 31, 2001

GROUP

1742

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No	
1.		0 823 713	2/11/1998	EPO		N/A	
2.		0 302 395	7/28/1988	EPO		N/A	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		Communication from European Patent Office re: counterpart application.

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Examiner:

Date Considered:

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